

ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18

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Title of Invention	YIELD IMPROVEMENT IN SILICON-GERMANIUM EPITAXIAL GROWTH	
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Application Number :

Confirmation Number:

First Named Applicant: Mark Dupuis

Attorney Docket Number: BUR920040106US1

Art Unit:

Examiner:

Search string: (5358895 or 20030139000).pn

US Patent Documents

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
	1	5358895	1994-10-25	Steele, et al			

US Published Applications

Note: Applicant is not required to submit a paper copy of cited US Published Applications

init	Cite.No.	Pub. No.	Date	Applicant	Kind	Class	Subclass
	1	20030139000	2003-07-24	Bedell, et al			

Signature

Examiner Name	Date